Docket No. 263787US26PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Hiroshi MASHIMA, et al.

SERIAL NO: 10/518,371 ART UNIT: 1792

FILING DATE: December 28, 2004 EXAMINER: GAMBETTA, KELLY M.

FOR: METHOD FOR PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION AND APPARATUS FOR

PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION

FEE TRANSMITTAL

No additional fee is required

☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.

The Fee has been calculated as shown below:

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	7 - 20 =	0	x \$52 =	\$0.00
INDEPENDENT CLAIMS	1 - 3 =	0	x \$220 =	\$0.00
☐ MULTIPLE DEPENDEN	T CLAIMS (If appl	icable)	+ \$390 =	\$0.00
☐ LATE FILING OF DECL	ARATION		+ \$130 =	\$0.00
			BASIC FEES	\$0.00
TOTAL OF ABOVE CALCULATIONS				\$0.00
☐ REDUCTION BY 50% FOR FILING BY SMALL ENTITY			\$0.00	
☐ FILING IN NON-ENGLI	SH LANGUAGE		+ \$130 =	\$0.00
			TOTAL	\$0.00

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If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030.

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The Director is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no payment is enclosed herewith, or credit any overpayment to Deposit Account No. <u>15-0030</u>.